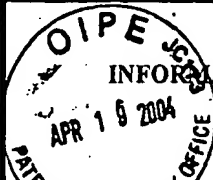




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 <p><b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)</p>	Docket Number (Optional) <b>62478-2100</b>	Application Number <b>09/650,029</b>
	Applicant(s) <b>Shinji Kawano</b>	
	Filing Date <b>August 28, 2000</b>	Group Art Unit <b>2144</b>

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE


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**FOREIGN PATENT DOCUMENTS**

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)

<p>LP</p>		<p>[Partial English Translation] for "Notification of Reasons for Refusal," issued on March 2, 2004 for corresponding Japanese Application No. 2000-273912, pages 1-6.</p>

EXAMINER 	DATE CONSIDERED <b>04/11/05</b>
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**EXAMINER:** Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.